

EXPEDITED PROCEDURE
Examining Group Number 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Craig K. Carlson-Stevermer	Examiner:	Jermele M. Hollington
Serial No.:	10/622,849	Group Art Unit:	2829
Filed:	July 18, 2003	Docket No.:	A126.114.102
Due Date:	February 22, 2007		
Title:	WAFER STAGING PLATFORM FOR A WAFER INSPECTION SYSTEM		

AMENDMENT AND RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is responsive to the Final Office Action mailed November 22, 2006. Please amend the above-identified patent application as follows:

*Please
enter
first*